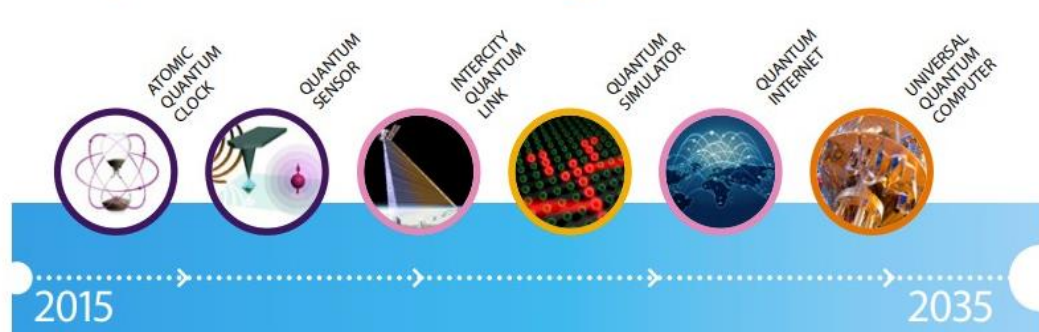


Research context and motivation

- Digital Assembly 2019: seven EU signed a declaration agreeing to explore together **how to develop and deploy a quantum communication infrastructure (QCI)** across the EU within the next ten years.
- 2018: €1 billion for the **Quantum Technologies Flagship**

Quantum Technologies Timeline



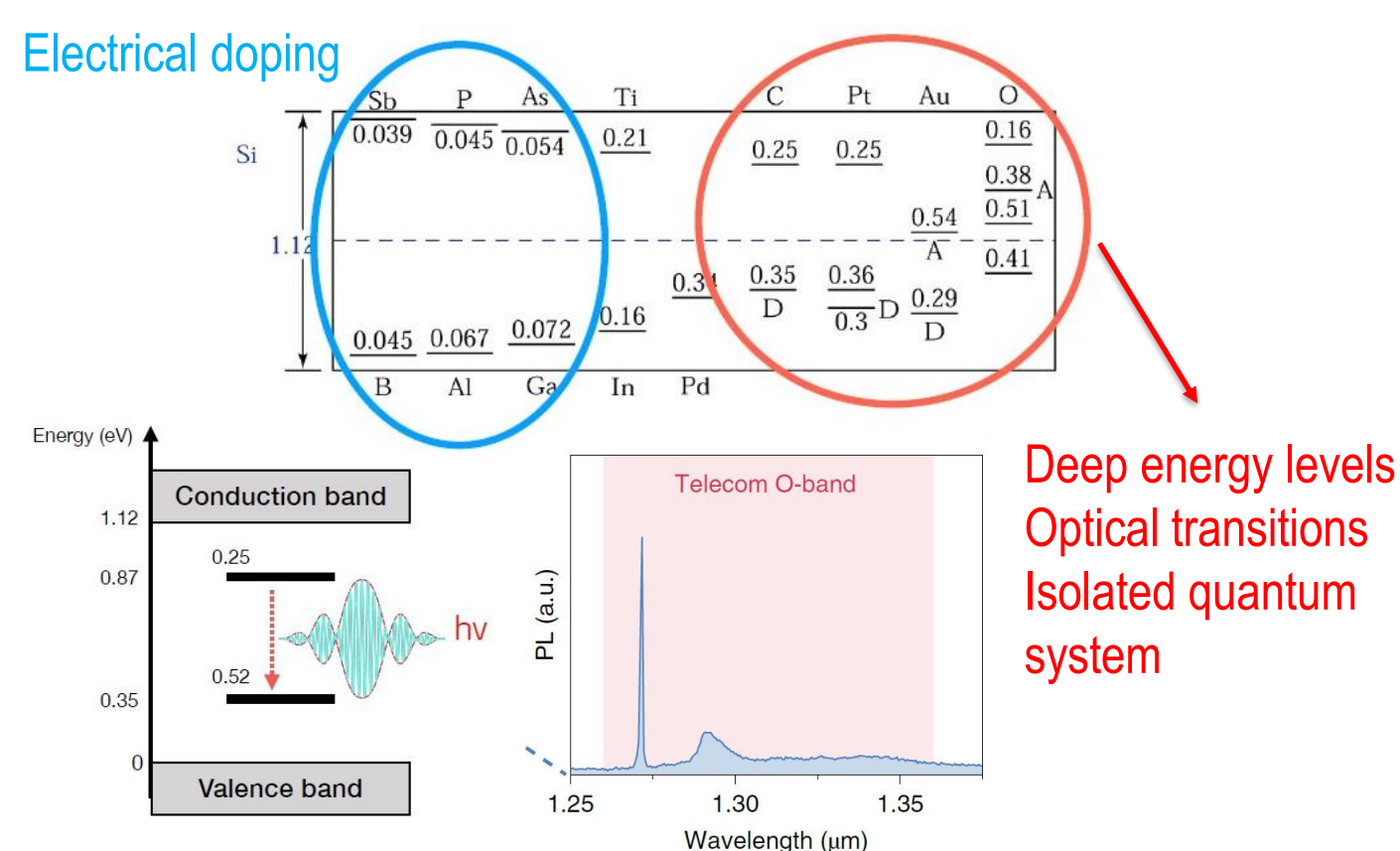
From the Quantum Manifesto (May 2016)

Photonic quantum technologies:

- Quantum cryptography (QKD)
- Quantum computing (qu-bit)
- Quantum sensing

Ideal single photon sources:

- High emission rate – short lifetime
- Monochromatic emission
- High quantum efficiency
- Stable emission (no blinking)
- Scalable physical system
- Telecom wavelength**



W Radjem et al., *Nature Electronics* volume 3, pages738–743 (2020)

Addressed research questions/problems

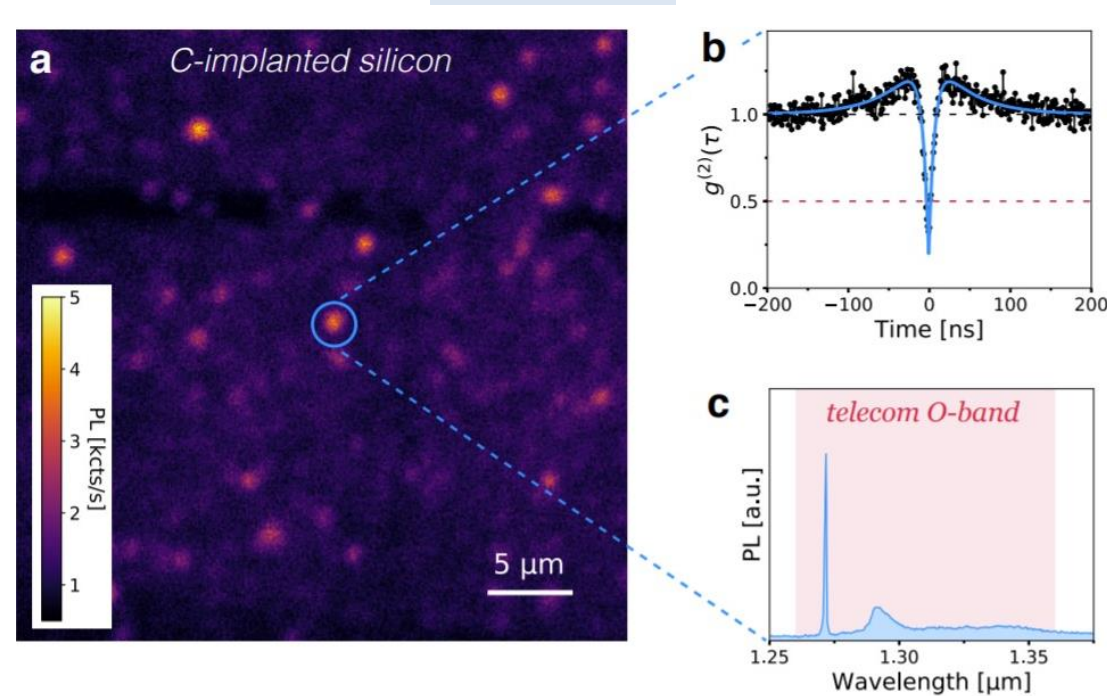
INFN QUANTEP project: Development and implementation of a complete Silicon Photonics Integrated Circuit for Quantum Computation with linear quantum optics circuits and single photons.

1. **Identification** of appealing classes of **emitter centers in the telecom C-band**
2. Ion implantation can unlock devices manufacturing through the **deterministic placement of emitters** registered to optical circuits

Colour centres in solid state materials (diamond, SiC, Si)

- ✓ Deterministic sources
- ✓ Compact (chip) size, portability, mass production
- ✓ Integration with existing micro-electronic technologies
- ✓ Low power consumption, environmentally friendly

Silicon



Scalable silicon-based quantum photonics device

Bright **telecom wavelength** single photon sources at Cryogenic temperature ($T < 110K$)

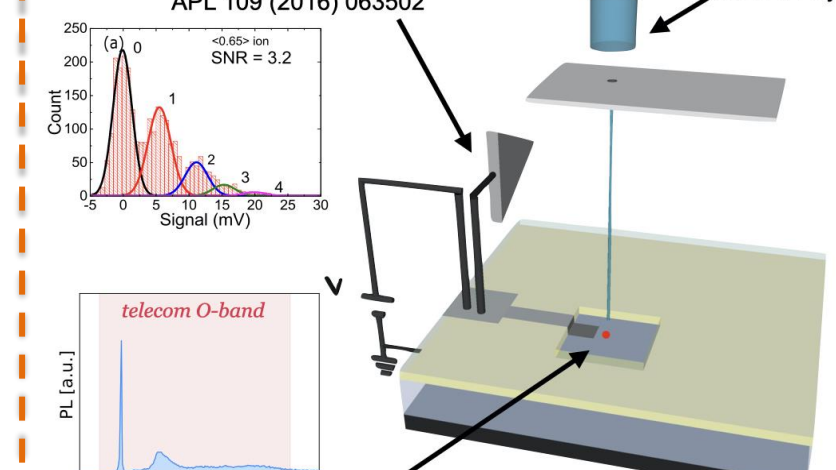
W Radjem et al., *Nature Electronics* volume 3, pages738–743 (2020)

Deterministic Implantation

- Nanoscale ion positioning
- **Single ion delivery**
- Formation yield

An irradiation chamber has been set up at the TO 100 kV ion implanter → reference structures on target sample itself to be used for **single ion detection** can be integrated

Single-ion detection



Ion Beam Induced Charge (IBIC) Technique:

- Single-ion sensitivity
- Same wafer to be processed by individual ions



IBIC map of a FIB machined Si photodiode

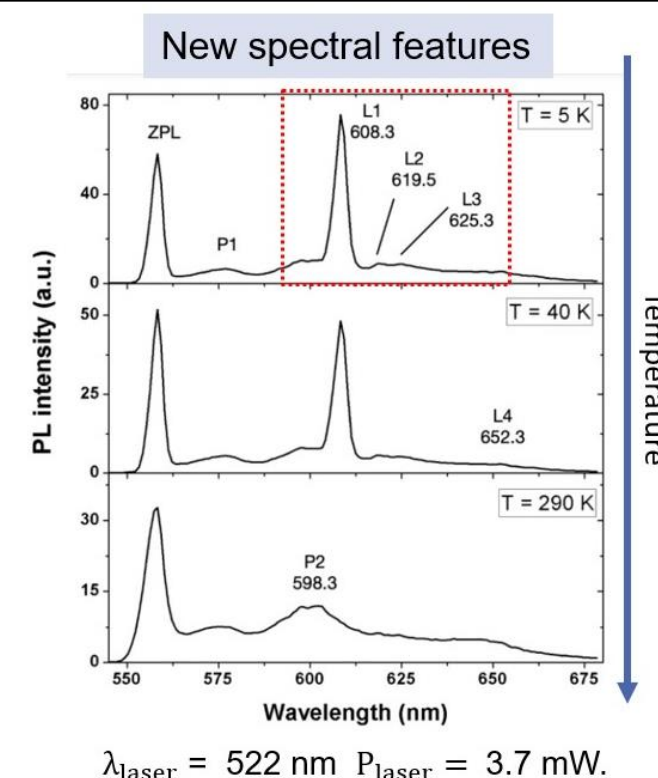
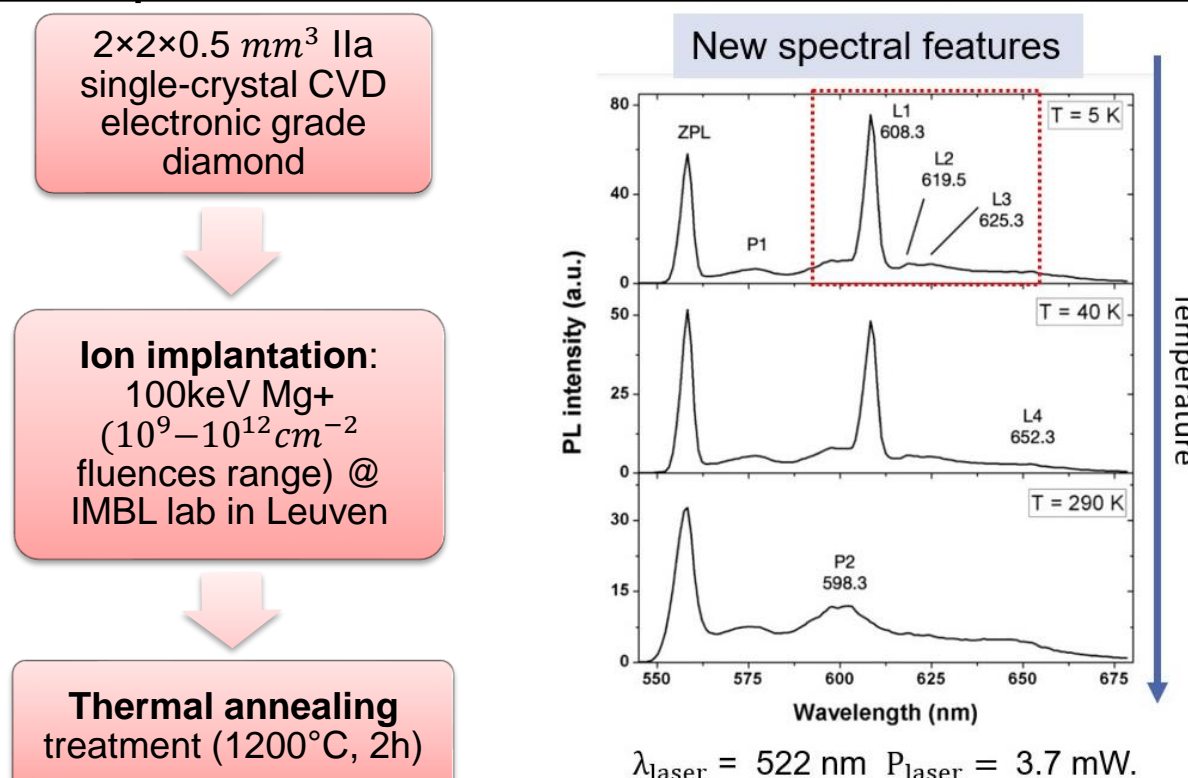
In situ measurement of the ion microbeam resolution has been demonstrated [1]

Submitted and published works

1. G. Andrini, E. Nieto Hernández, G. Provas, M. Brajkovic, A. Crnjac, S. Ditalia Tchernij, J. Forneris*, V. Rigato, M. Campostrini, Z. Siketic, M. Jaksic, E. Vittone "An ion beam spot size monitor based on a nano-machined Si photodiode probed by means of the ion beam induced charge technique", *Vacuum*, vol. 205, no. 111392, 2022
2. E. Corte, G. Andrini, E. Nieto Hernández, V. Pugliese, A. Costa, G. Magchiels, J. Moens, S. M. Tunhuma, R. Villarreal, L. M.C. Pereira, A. Vantomme, J. Guilherme Correia, E. Bernardi, P. Traina, I. P. Degiovanni, E. Moreva, M. Genovese, S. Ditalia Tchernij, P. Olivero, U. Wahl, J. Forneris "Magnesium-vacancy optical centers in diamond", arXiv:2206.08670, June 2022

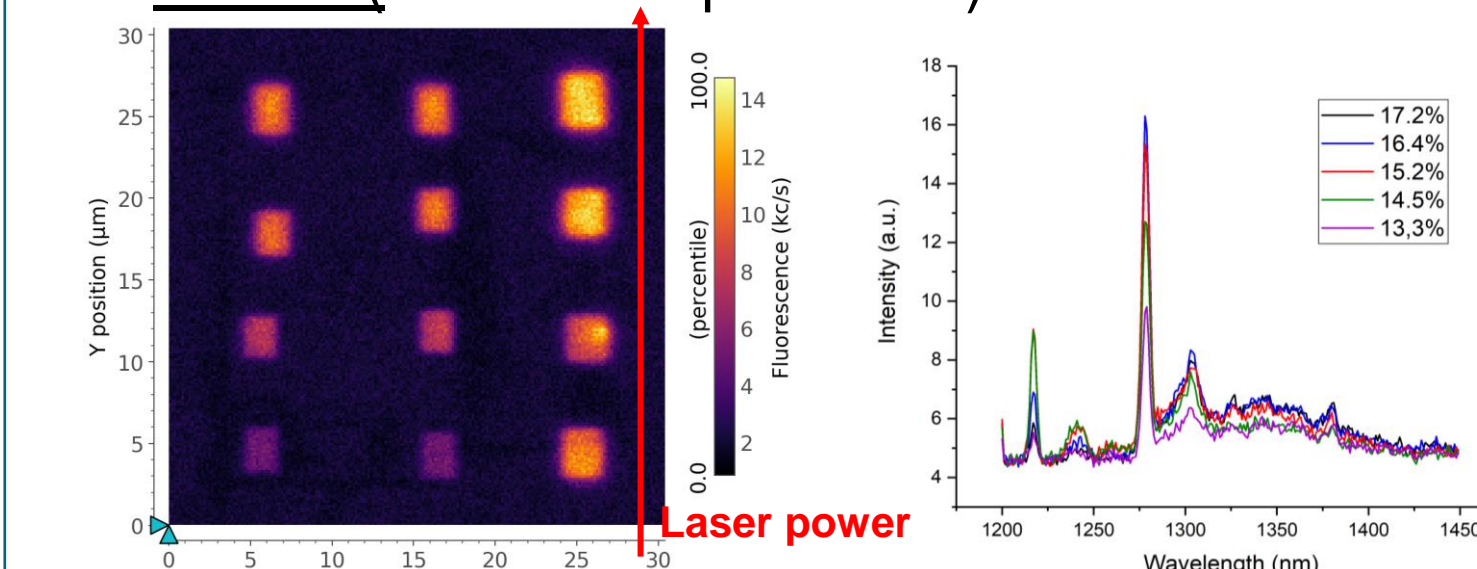
Novel contributions

- 1) Assessment of a **single-photon sensitive cryogenic confocal microscope: Mg-related quantum emitters in diamond as a case study**



- ✓ First **systematic experimental analysis** of the structural and **photophysical** properties of **MgV centers** fabricated upon ion implantation in artificial diamond [2]
- Previously **unexplored emission properties** have been demonstrated at **cryogenic temperatures**

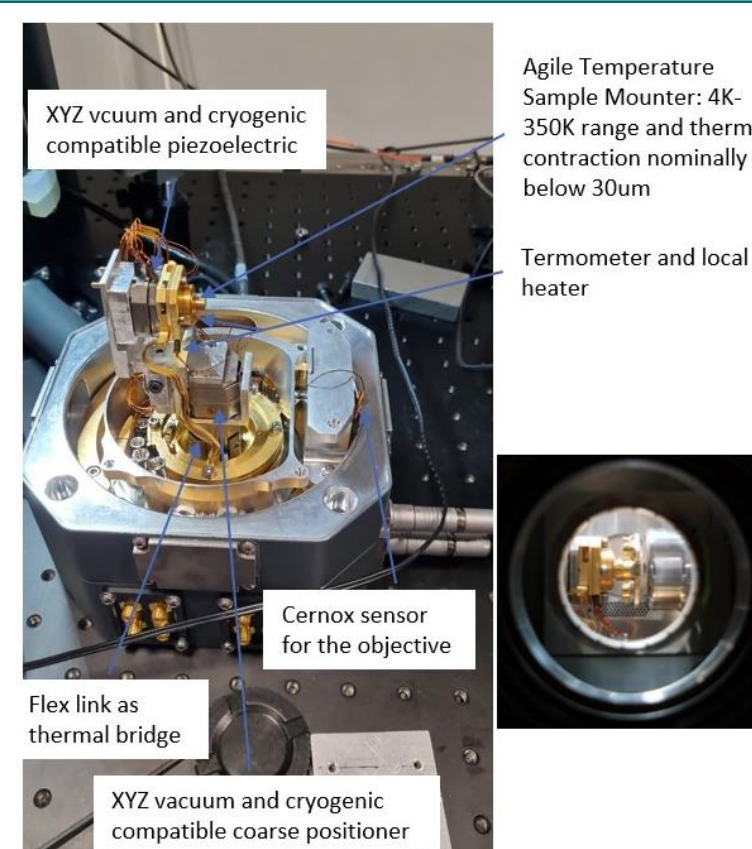
- 2) **Laser annealing activation of C-based emitters in silicon (36keV C implantation)**



- ✓ Single-photon sensitive **cryogenic** confocal microscope (4-300 K) operating in the **IR and VIS** range
- ✓ **Investigation of laser annealing protocol for colour centres activation in silicon** (so far, any other contribution reported in literature)

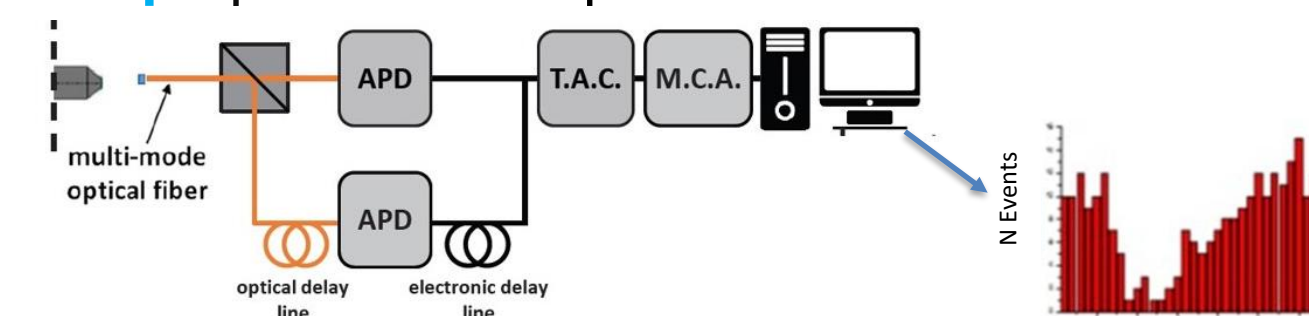
PL maps of the C implanted silicon sample, $\lambda_{exc} = 488nm$, $P_{laser} = 2mW$ and PL spectra acquired in different laser annealed regions corresponding to different laser powers

Adopted methodologies



Hanbury-Brown & Twiss Interferometry for experimental measurement of second order autocorrelation function allows to identify and analyze single-photon emitters.

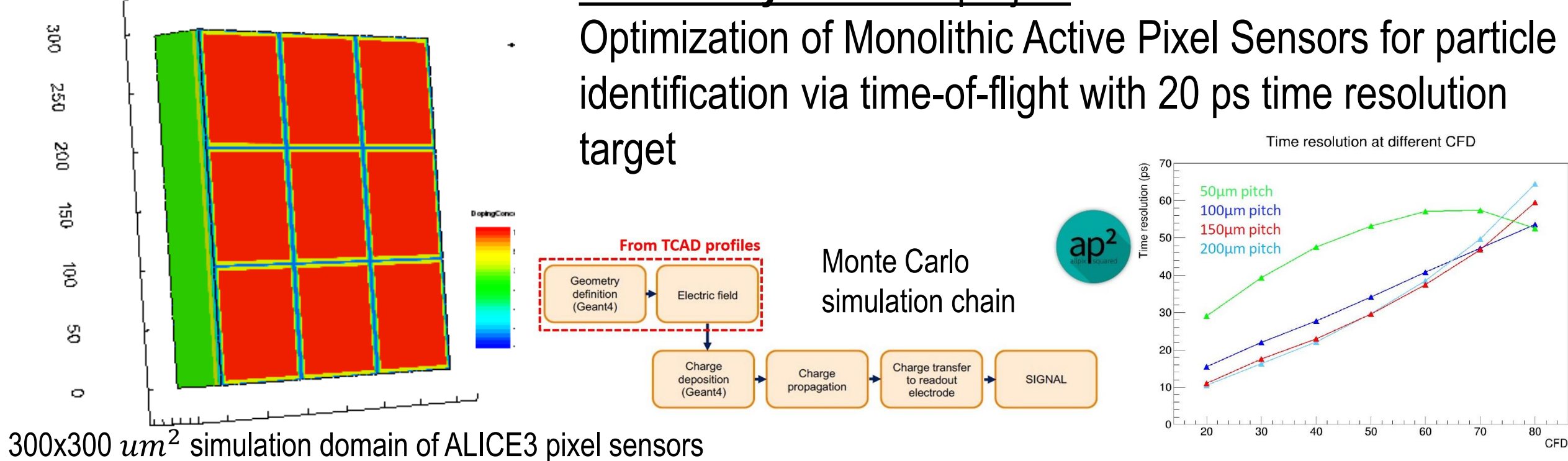
A **closed-cycle optical cryostat** by Montana Instruments together with a **single-photon sensitive confocal microscope** permits the optical characterization down to 4K.



Technology Computer-Aided Design can be a valuable resource in the optimization of the target itself as a solid-state particle detector for the **deterministic positioning of impurities** in silicon

Case study: ALICE 3 project

Optimization of Monolithic Active Pixel Sensors for particle identification via time-of-flight with 20 ps time resolution target

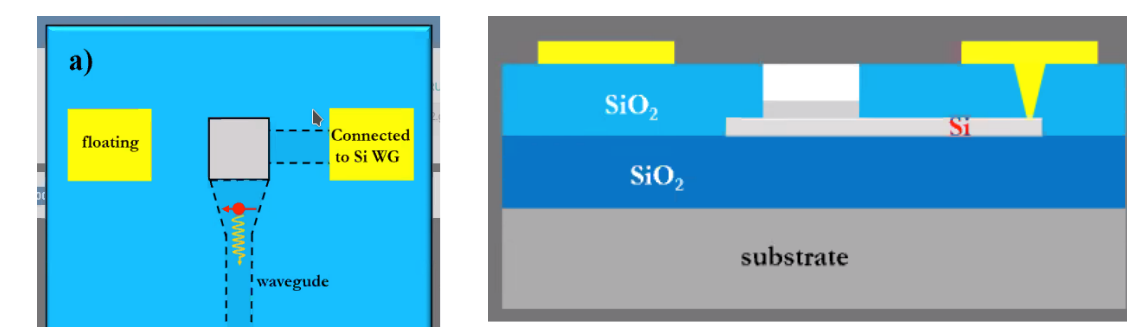


300x300 μm^2 simulation domain of ALICE3 pixel sensors

Future work

- **Identification** of C-based **single-photon** emitters in Si
- **Activation** of C-based **single-photon** emitters in Si with laser annealing process
- Comparison with standard annealing processes
- Deterministic placement of single photon emitters in a Complete Silicon Photonics Integrated Circuit:

- 1) Sensor design?
- 2) Suitable doping profiles?
- 3) keV single ion signal estimation?



Sketch of exposed silicon waveguide area ($5 \times 5 \mu m^2$) from the INFN QUANTEP project

List of attended classes

- 02LWHRV – Communication(12/02/2022, 6.67)
- 01RISRV – Public Speaking(13/02/2022, 6.67)
- 01DMLKG – Introduzione all'ottica ed alle Tecnologie quantistiche(24/03/2022, 41.67)
- 01DOMKG – Introduzione alla microscopia ottica - Scienza e Tecnologia (didattica di eccellenza vp)(23/05/2022, 33.3)
- 01QRGRV – Microelectronics for radiation detectors I(29/06/2022, 30h, exam in October 2022)
- Summer School on Advanced Photonics and Electronics for Quantum and Space Application(29/8/2022, 14)
- Summer School on Ion Implantation Technology(22/09/2022, credits to be approved)